

<b>Notice of References Cited</b>	Application/Control No. 10/717,145	Applicant(s)/Patent Under Reexamination O'BRIEN, STEPHEN	
	Examiner James J. DeBrow	Art Unit 2176	Page 1 of 1

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**NON-PATENT DOCUMENTS**

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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